



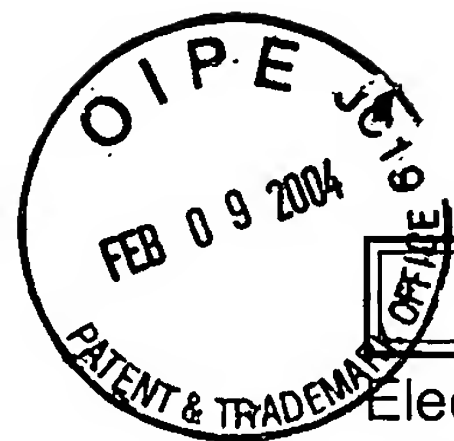
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Electronic Patent Application Submission
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Application ID: 10621303
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MECHANICAL POLISHING
First Named Inventor: Donald Olgado
Domestic/Foreign Application: Domestic Application
Filing Date: 2003-07-16
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Electronic Version v1.1

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Title of Invention	LOAD CUP FOR CHEMICAL MECHANICAL POLISHING									
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<table border="1"><thead><tr><th>Submitted by:</th><th>Elec. Sign.</th><th>Sign. Capacity</th></tr></thead><tbody><tr><td>Keith P Taboada Registered Number: 45150</td><td>/Keith Taboada/</td><td>Attorney</td></tr></tbody></table>			Submitted by:	Elec. Sign.	Sign. Capacity	Keith P Taboada Registered Number: 45150	/Keith Taboada/	Attorney		
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<table><tr><td>Documents being submitted</td><td>Files</td></tr><tr><td>us-ids</td><td>APPM7125-usidst.xml</td></tr><tr><td></td><td>us-ids.dtd</td></tr><tr><td></td><td>us-ids.xsl</td></tr></table>			Documents being submitted	Files	us-ids	APPM7125-usidst.xml		us-ids.dtd		us-ids.xsl
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Comments										



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